

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Masaharu Nagai et al.                      Art Unit :                      1795  
Serial No. : 10/694,986                      Examiner :                      Daborah Chacko Davis  
Filed : October 29, 2003                      Confirmation No.:                      5334  
   Notice of Allowance Date: June 21, 2010  
Title : METHOD FOR REMOVING RESIST PATTERN AND METHOD FOR  
MANUFACTURING SEMICONDUCTOR DEVICE

**MAIL STOP ISSUE FEE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO NOTICE OF ALLOWANCE**

In response to the Notice of Allowance mailed June 21, 2010, enclosed is a completed issue fee transmittal form PTOL 85b. The fees in the amount of \$1810 for the issue fee (\$1510) and the publication fee (\$300) are being paid concurrently herewith on the Electronic Filing System (EFS) by way of Deposit Account authorization.

Please apply any additional charges or credits to our Deposit Account No. 06-1050.

Respectfully submitted,

Date: September 20, 2010

  
John F. Hayden  
Reg. No. 37640

Customer Number 26171  
Fish & Richardson P.C.  
Telephone: (202) 783-5070  
Facsimile: (877) 769-7945